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## APPLICANTS

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*None MG*  
 \*\* CONTINUING DATA \*\*\*\*\*

*OK MC*  
 \*\* FOREIGN APPLICATIONS \*\*\*\*\*  
 REPUBLIC OF KOREA 2002-067120 10/31/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Maria G. Silvera</i> MC Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 9	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 12
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TITLE  
 Method of forming polysilicon thin film transistor

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